



Attorney's Docket No.: 4936 USA/ETCH/METAL/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent
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In Re Application of:

Steven Verhaverbeke et al.

U.S. Serial No: 09/945,454

Filed: August 31, 2001

For: A METHOD AND APPARATUS
FOR PROCESSING A WAFER

Examiner: Moore, Karla A.

Art Unit: 1763

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Final Office Action mailed August 25, 2003 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Amendment and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____

COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450

U.S. Patent and Trademark Office, Washington, D.C. 20231 on Monday, January 26, 2004

Date of Deposit

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January 26, 2004
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